

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:	Shiow-Hwei Hwang et al.		
Title:	System and Method for Coherent Optical Inspection		
Application No.:	10/678,920	Filing Date:	October 2, 2003
Examiner:	Detschel, Marissa	Group Art Unit:	2877
Docket No.:	TNCR.210US1	Conf. No.:	1403

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Mail Stop Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT UNDER 37 C.F.R. §1.312**

Sir:

Please amend the above-identified application as follows:

Specification Amendments begin on page 2 of this paper.

Remarks begin on page 3 of this paper.